



2201 X4
2202 X4/2/6S
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XA-9608
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Naoyuki KOFUJI et al.

Appln. No.: 10/043,180

Group Art Unit: 1765

Filed: January 14, 2002

Examiner: T. Mackey

For: METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE

SUPPLEMENTAL AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In supplemental response to the Office Action mailed June 23, 2003, please amend the above-identified patent application as indicated below.

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 13 of this paper.

12/17/2003 AADOFD1 00000047 10043180

01 FC:2201	172.00 OP
02 FC:2202	378.00 OP